

Electronic Information Disclosure Statement

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SEMICONDUCTOR WITH CONTACT AND RELATED METHODS

Application:

Confirmation:

Applicant(s): Toshiharu Furukawa

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Group Art Unit:

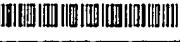
Examiner:

search string: (6316311 or 6294449 or 6281143 or 6274471 or 6274468 or 6271108 or 5997757 or 5928969 or 5899742 or 5792703 or 5691561 or 5464793).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Citation No.	Patent Number	Date	Bar Code	Patentee	Class	Subclass
Vn	P01	6316311	2001-11-13		Chen		
	P02	6294449	2001-09-25		Wu et al.		
	P03	6281143	2001-08-28		Huang et al.		
	P04	6274471	2001-08-14		Huang		
	P05	6274468	2001-08-14		Hsu		
	P06	6271108	2001-08-07		Choe		
	P07	5997757	1999-12-07		Nagayama et al.		
Vn	P08	5928969	1999-07-27		Li et al.		

<input checked="" type="checkbox"/>	P09	5899742	1999-05-04		Sun	
<input type="checkbox"/>	P10	5792703	1998-08-11		Bronner et al.	
<input type="checkbox"/>	P11	5691561	1997-11-25		Goto	
<input checked="" type="checkbox"/>	P12	5464793	1995-11-07		Roehl	

Signature

Examiner Name	Date
HUNG VU	04/04/05